THIS TECHNOLOGY IS CURRENTLY NOT AVAILABLE FOR LICENSING

Tech ID: 33850

ADDITIONAL TECHNOLOGIES BY THESE INVENTORS

- Apodization Specific Peak Fitting In Charge Detection Mass Spectrometry
- Multiplex Charge Detection Mass Spectrometry
- Sequential Pass Express Charge Detection Mass Analyzer
- Ambient infrared laser ablation mass spectrometry (AIRLAB-MS) with plume capture by continuous flow solvent probe
- Aerosol Ionization For Charge Detection Mass Spectrometry Ion Mobility Analysis

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